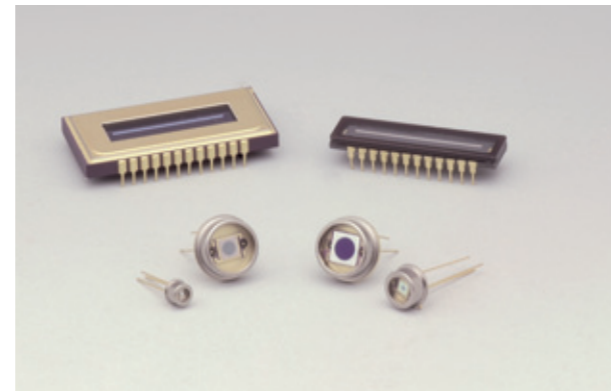


# IR-enhanced Si devices

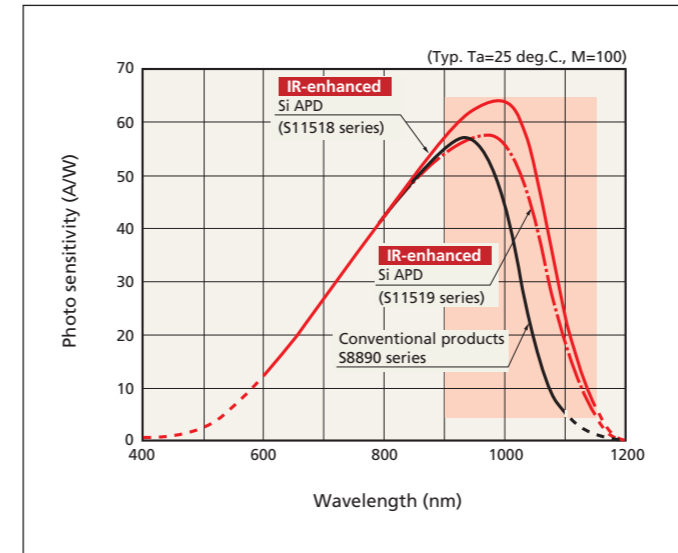
## Next-generation Si devices with enhanced near IR sensitivity, using a MEMS structure

Introducing the next-generation of ultra high sensitivity semiconductor sensors that exceed the performance of existing Si photodiodes, Si APDs, and CCD image sensors. These sensors have MEMS (Micro-Electro-Mechanical-Systems) structures fabricated using our own unique laser processing technology and achieve very high sensitivity in the near infrared region. They are the ideal solution for a wide variety of applications such as optical communications, thermal measurement and fluorescence photometry.

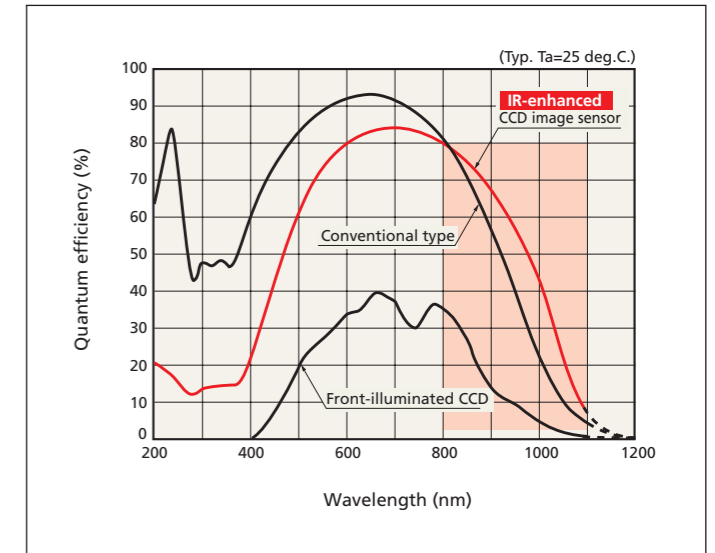


IR-enhanced Si line-up

Spectral response (IR-enhanced Si APD)

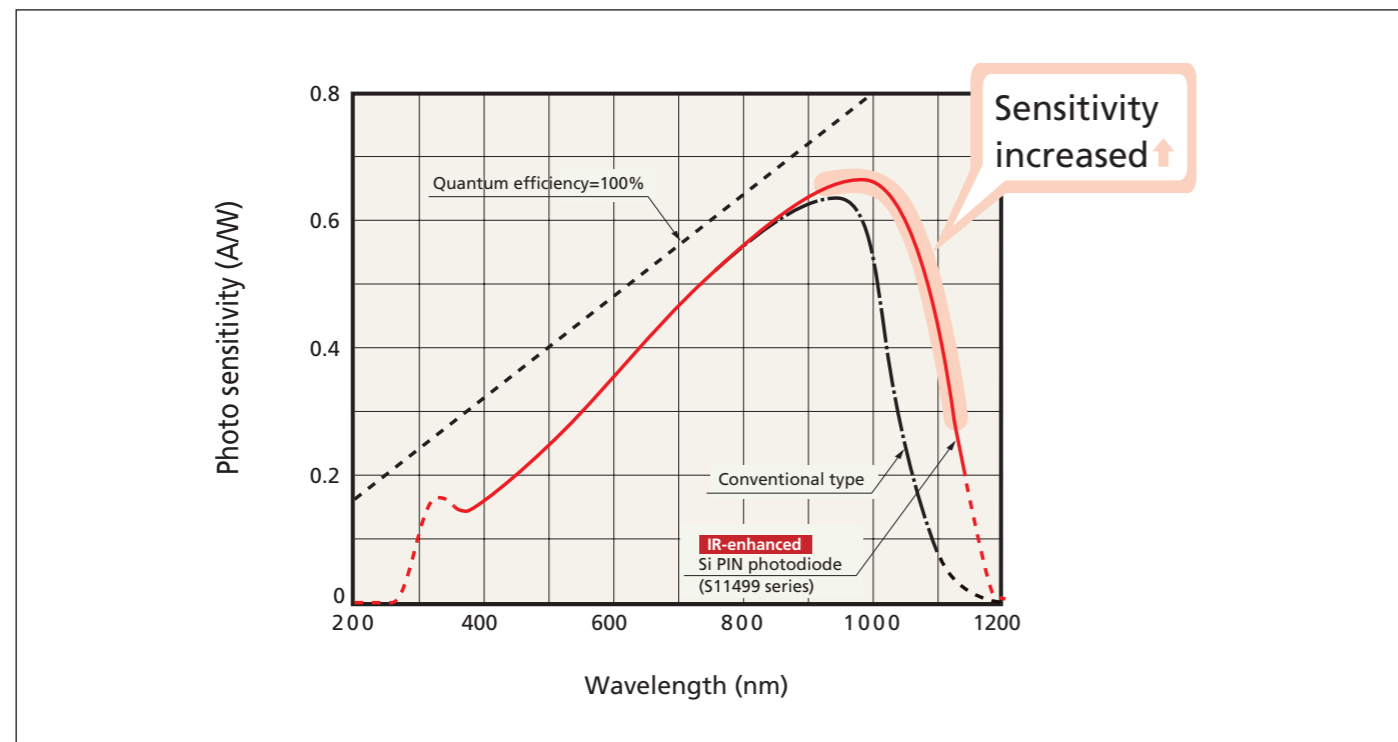


Spectral response (IR-enhanced CCD image sensor)



Spectral response (IR-enhanced Si PIN photodiode)

(Typ. Ta=25 deg.C)



Line-up

(Typ. Ta=25 deg.C., unless otherwise noted)

| Product                       |                   | Type No.    | Conventional products | Active area size         | Package            | Application                  | Page No. |
|-------------------------------|-------------------|-------------|-----------------------|--------------------------|--------------------|------------------------------|----------|
| IR-enhanced Si PIN photodiode | High speed        | S11498      | S9055                 | Ø 0.2 mm                 | TO-18              | Optical fibre communications | P.12     |
|                               |                   | S11498-01   | S9055-01              | Ø 0.1 mm                 | TO-18              |                              |          |
|                               | Large active area | S11499      | -                     | Ø 3 mm                   | TO-5               | YAG laser monitor            | P.12     |
| IR-enhanced APD               | High sensitivity  | S11518-10   | S8890-10              | Ø 1 mm                   | TO-5               | YAG laser monitor            | P.13     |
|                               |                   | S11518-30   | S8890-30              | Ø 3 mm                   | TO-8               |                              |          |
|                               | Low voltage       | S11519-10   | S8890-10              | Ø 1 mm                   | TO-5               |                              |          |
|                               |                   | S11519-30   | S8890-30              | Ø 3 mm                   | TO-8               |                              |          |
| IR-enhanced CCD image sensor  |                   | S11500-1007 | S7030-1007            | 24 x 24 µm/1024 x 128 ch | Ceramic Non-cooled | Raman spectrometers          | P.14     |
|                               |                   | S11510-1006 | S10420-1006           | 14 x 14 µm/1024 x 64 ch  |                    |                              |          |
|                               |                   | S11510-1106 | S10420-1106           | 14 x 14 µm/2048 x 64 ch  |                    |                              |          |

# IR-enhanced Si PIN photodiodes S11498 series, S11499 series

## IR-enhanced Si PIN photodiodes

The S11498 series and S11499 series are a family of Si PIN photodiodes which use Hamamatsu's new MEMS structure to offer a drastic improvement in sensitivity in the near infrared region at longer wavelengths.

### Si PIN Photodiodes S11498 series

#### Features

- High sensitivity: 0.4 A/W (850 nm)
- High speed
  - 1.5 GHz (S11498)
  - 2.0 GHz (S11498-01)
- Low capacitance

#### Applications

- Optical fibre communications
- High speed measurement

### Si PIN Photodiodes S11499 series

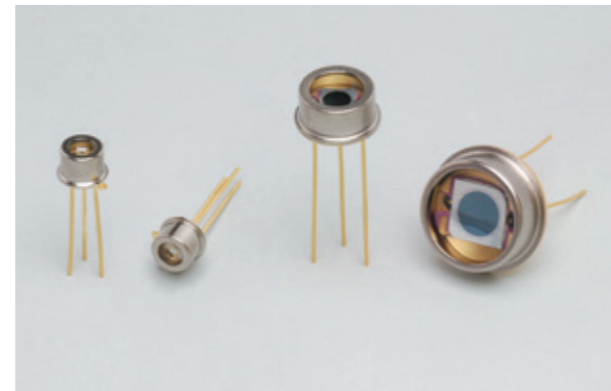
#### Features

- High sensitivity: 0.6 A/W (1060 nm)
- Large active area
  - φ 3.0 mm (S11499)
  - φ 5.0 mm (S11499-01)

#### Applications

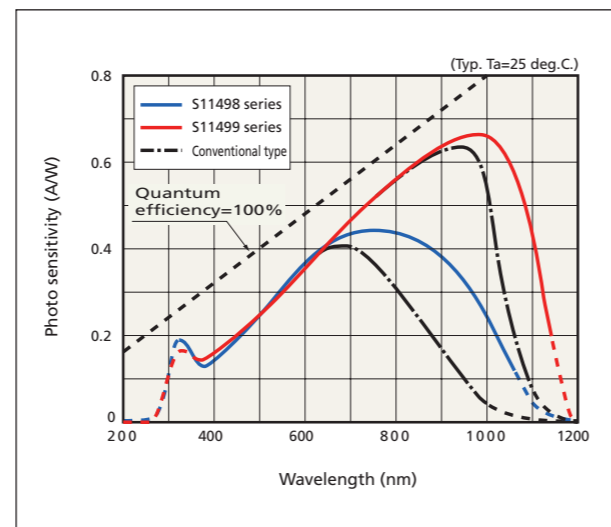
- YAG laser monitor

Author: Robin Smith, Hamamatsu Photonics UK



S11498/S11498-01 (left), S11499/S11499-01 (right)

Spectral response



## IR-enhanced Si APD

The S11518 series and S11519 series are a family of Si APDs which use Hamamatsu's new MEMS technology to offer 40% quantum efficiency at 1.06 μm.

The S11518 series can replace the S8890 series whilst offering almost double the quantum efficiency at 1.06 μm, making this series ideal for YAG laser monitoring.

The S11519 series is designed for operation at low bias and offers excellent characteristics and stable operation at just 350 V.

### Features

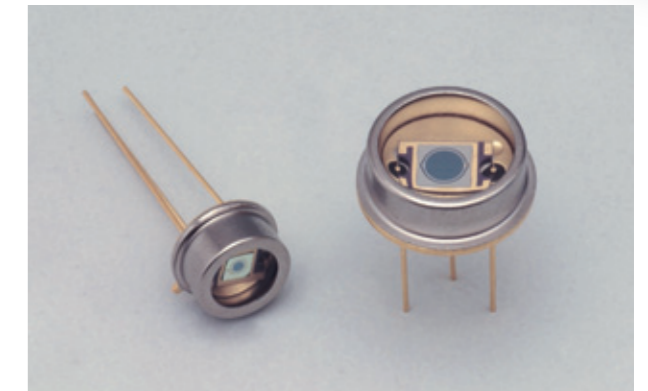
- High sensitivity in the near infrared region
- High gain
- S11519 series: stable operation at low bias

### Applications

- YAG laser monitor

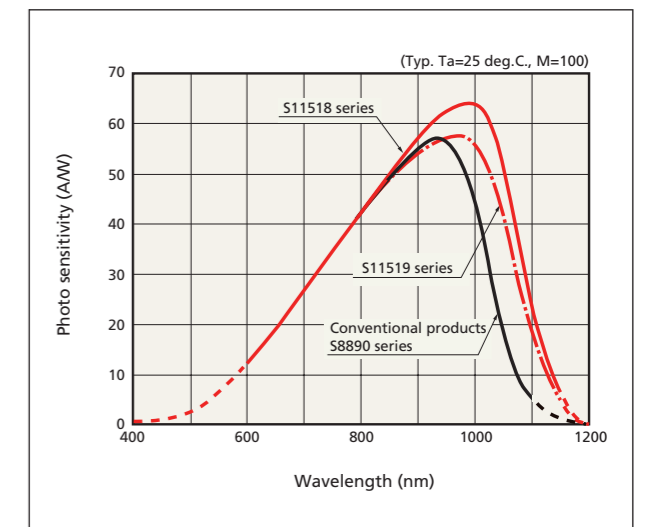
Author: Robin Smith, Hamamatsu Photonics UK

# IR-enhanced Si APDs S11518 series, S11519 series



S11518-10/S11518-30 (left), S11519-10/S11519-30 (right)

Spectral response



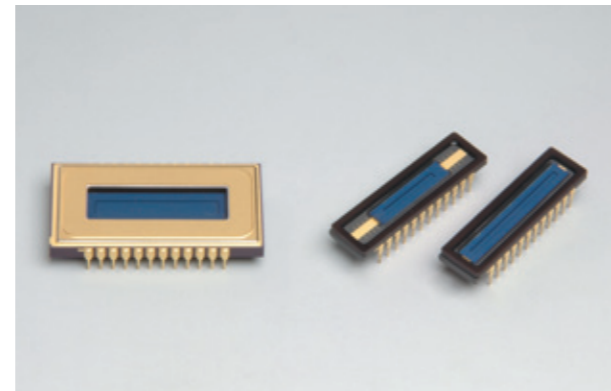
# IR-enhanced CCD image sensors S11500-1007, S11510 series

# New InGaAs PIN photodiodes G11193 series

## IR-enhanced CCD image sensors

The S11500-1007 and S11510 series are FFT (Full Frame Transfer) CCD image sensors which feature improved sensitivity in the near infrared region and a quantum efficiency of 40% at 1000 nm through the use of a MEMS structure on the back side of the CCD.

Although these are area image sensors they can also be used as linear sensors through the implementation of binning, making these products ideal for spectroscopy applications.



S11500-1007 (left), S11510-1006 (middle), S11510-1007 (right)

### CCD area image sensor S11500-1007

#### Features

- Pixel size: 24 x 24  $\mu\text{m}$
- Line, pixel binning
- Wide spectral response range
- Low readout noise
- Wide dynamic range

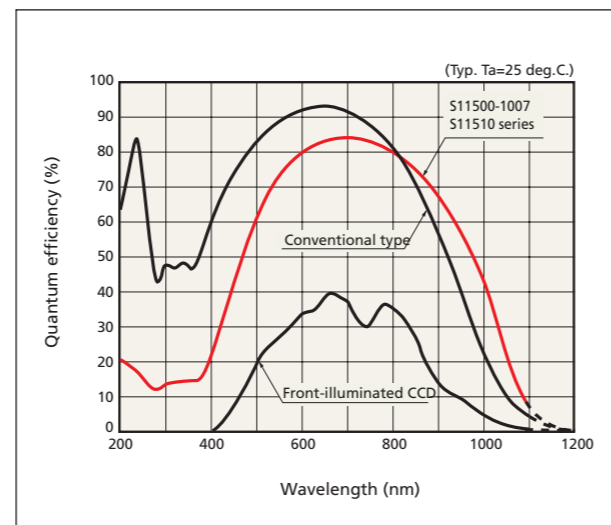
### CCD image sensors S11510 series

#### Features

- Pixel size: 14 x 14  $\mu\text{m}$
- High CCD node sensitivity: 6.5  $\mu\text{V}/\text{e}$
- Wide spectral response range
- Wide dynamic range

Author: Robin Smith, Hamamatsu Photonics UK

Spectral response



## Small surface mount package PIN diodes

The new G11193 series of InGaAs PIN photodiodes feature a small, compact SMD (Surface Mount Device) package, measuring just 5 mm x 4 mm. Two types are available, with differing active areas of 0.2 mm and 0.3 mm diameter respectively.

The G11193 series feature low noise and low dark current characteristics and are ideal for optical power meter and general IR measurement applications.

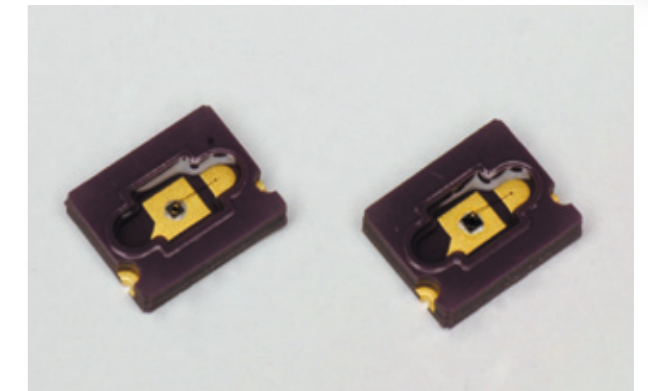
### Features

- 0.9  $\mu\text{m}$  - 1.7  $\mu\text{m}$  spectral response range
- Small SMD package
- Low dark current

### Applications

- Optical power meter
- General measurement
- Analytical instrumentation

Author: Richard Harvey, Hamamatsu Photonics UK



G11193 series

General ratings

(Typ. Ta=25 deg.C.)

| Parameter   | G11193-02R | G11193-03R | Unit |
|-------------|------------|------------|------|
| Package     | SMD        |            | -    |
| Active area | $\phi$ 0.2 | $\phi$ 0.3 | mm   |
| Window      | Resin      |            | -    |

Spectral response

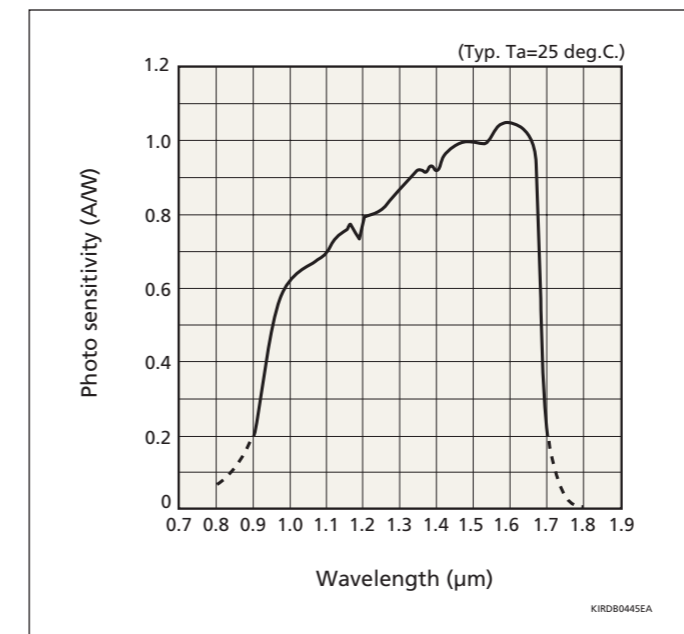


Photo sensitivity temperature characteristic

